CENTRAL FAX CENTER

Atty. Docket No: MTRL020US0

MAR % 9 2005

Customer ID No. 37141

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Balgovind K. Sharma

Serial No.:

10/618,228

Filing Date:

July 11, 2003

Examiner:

Tran, Binh X.

Art Unit:

1765

Title:

MICELLAR TECHNOLOGY FOR POST-ETCH RESIDUES

Certification Under 37 C.F.R. 1.8

Date of Mailing: March 22, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that I have caused the documents indicated herein to be facsimile transmitted to the U.S. Patent Office under 37 CFR § 1.8 on the date indicated above.

Reina R. Bernfel

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(c)(2)

Dear Sir:

Applicants respectfully request, pursuant to 37 C.F.R. §§ 1.97 and 1.98, that the art listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application.

Citation of the documents shall not be construed as:

- 1) an admission that the documents are necessarily prior art with respect to the instant invention;
 - 2) a representation that a search has been made, other than as described above; or
- 3) an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

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Applicants enclose herewith the fee according to 37 CFR § 1.17(p), however, if any further fees or credits are due, the Commissioner is hereby authorized to charge or credit Fortkort Grether + Kelton LLP, Deposit Account No. 50-2726.

Should the Examiner have any questions or desire clarification of any sort, the Examiner is invited to telephone the undersigned at the number listed below. Please reference Attorney Docket No. MTRL020USO.

Respectfully submitted,

FORTKORT GRETHER + KELTON LLP

Date: 3-22-2005

y: — (-++-)

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	STATEMENT 6	BY A	PPLICANT	First Named Inventor	Sharma, B.	
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				Examiner Name	Tran, Binh X.	
Sheet	1	Of	1	Attorney Docket Number	MTRL020US0	

	U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document mm-dd-yy	Class	Subclass	
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Foreign Patent Documents									
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Non Patent Literature Documents		
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		International Sematech, "Low-K Dielectrics"; 2001 Annual Report; 2 pages

Examiner	Date
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